

212/361

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re Application of:

Kassir

Serial No.: 10/059,701

Art Unit: 1765

Filed: January 29, 2002

For: Method of Spin Etching
Wafers with an Alkali Solution

Examiner: Makey, T.

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions for a 3 month extension of time to respond to the Office Action mailed on June 19, 2003.

A petition fee of \$465 is due. The Commissioner is hereby authorized to charge payment of the fees associated with this communication, any deficiency in the fee paid, or credit any overpayment, to Deposit Account 03-3700.

Date: December 18, 2003

By:

Theodore D. Fay III

Theodore D. Fay III
Reg. No. 48504